

Scintillator tile uniformity scans for Sc-ECAL

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CALICE collaboration meeting – 09/2013



- Questions:
 - Optimum dimensions of the tiles?
 - How small / thin can the tiles be?
- ← Simulation ← Hardware
- Longitudinal arrangement? Hybrid mode of Si / Sc?
- Transversal arrangement?
- To answer these questions, we need:
 - SiPM & scintillator characterization: dark rate, afterpulses, saturation, temperature dependence, crosstalk
 - Study uniformity, study SiPM to tiles connection

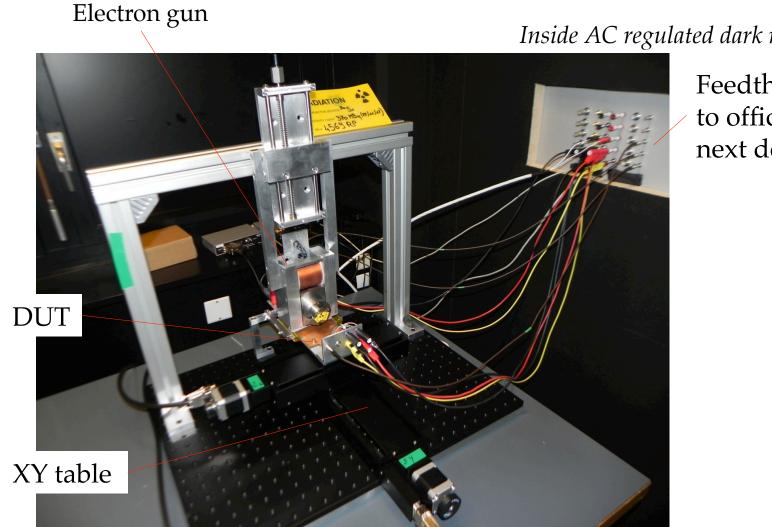
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 Steps which have already been performed by CALICE – First steps are for our understanding, not to reinvent the wheel.

This talk:

• Setup at CERN LCD/DT lab & first uniformity studies.





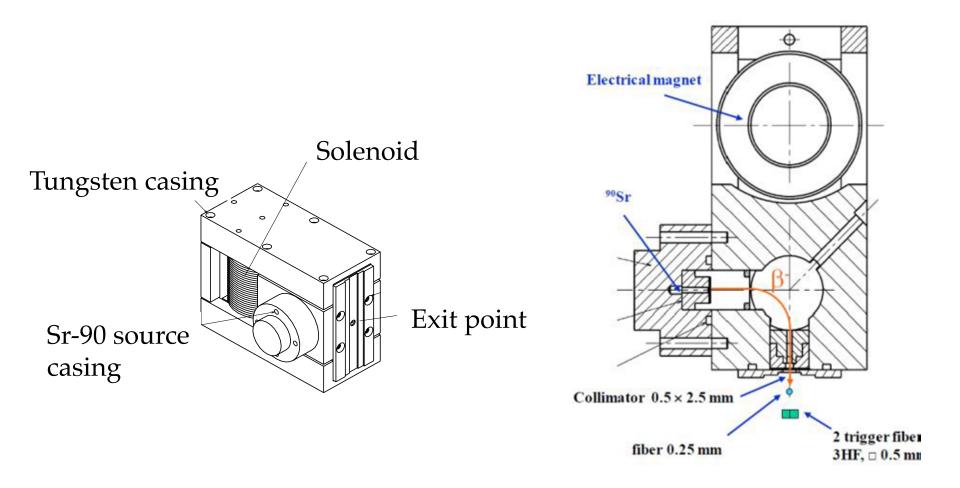
Inside AC regulated dark room

Feedthrough to office/lab next door

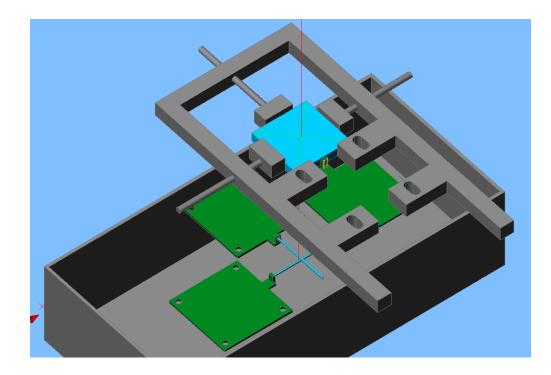


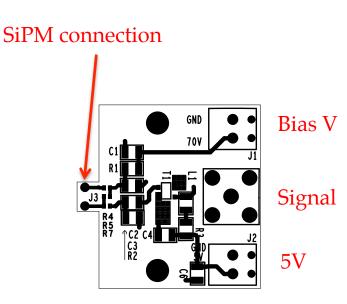
350 MBq Sr-90 source

• Selectable electron energy ~1 < E < ~2 MeV



Trigger setup & readout circuit





Same as MPI board, with Infineon BGA 614 amplifier, redesigned to 25x22 mm².

- Crossed scintillating fibers (20x1x1 mm³) as trigger, fixed underneath DUT.
- Positioned Hamamatsu MPPC (50 um pitch) on a nose, sticking out 2 mm beyond the edge, for readout of tiles with dimples
- Including Pt1000 probe near SiPM.

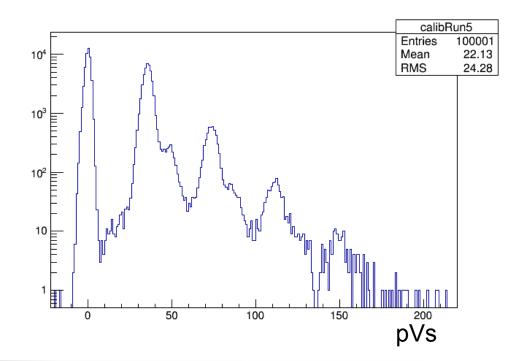


- Data acquisition:
 - Digital oscilloscope: 4 GHz 4-channel picoscope
 - LabView VI \rightarrow readout trigger by trigger
 - Rate is limited by electron gun & tile thickness to O(20) Hz.

Calibration:

- With the gun off, acquire Single Photon spectrum run
- At the center of tile, define gain at nominal temperature





30x30x3mm³ scan result

Tile wrapped in ESR foil, SiPM pushed against opening (from top)

Scan tile in X and Y direction in steps of 1mm

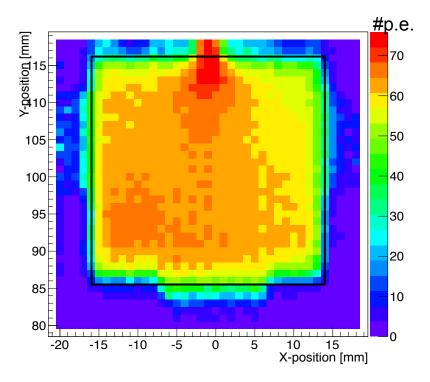
• Trigger on crossed-fibers coincidence

At each scan step (60s), record:

- Temperature
- Each triggered waveform integral

Assuming dG/dT = 3.4% / K:

- Correct gain for T fluctuation
- Transform waveform into #pe
 - Response from plastic tile-holders left/right/down visible



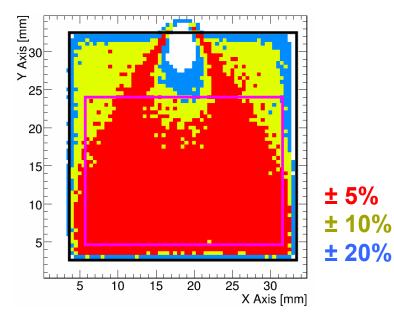
30x30x3 mm³:

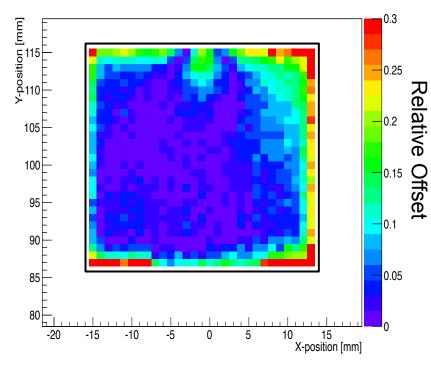
- Average response ~ 60 p.e.
- Left-right asymmetry
 - Non-uniform wrapping?
 - Temperature?
 - SiPM to tile connection?

30x30x3mm³ scan result – relative offset

Tile wrapped in ESR foil, SiPM pushed against opening (from top)

• Compared to T3B 30x30x5mm³:



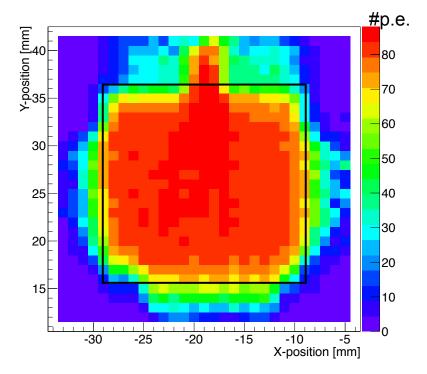


30x30x3 mm³:

• The uniformity resembles the distribution as measured by T3B

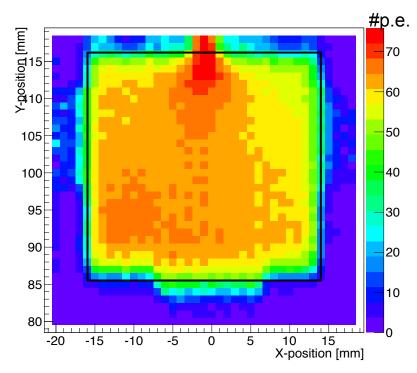


Two tile sizes – both wrapped in ESR foil



20x20x2 mm³:

- Average response ~ 80 p.e.
 - SiPM:tileside ratio increased.
- Left-right asymmetry less pronounced
- Response near SiPM similar to average response

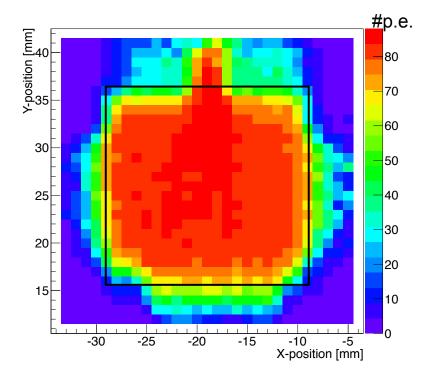


30x30x3 mm³:

- Average response ~ 60 p.e.
- Left-right asymmetry
- Response near SiPM relatively high

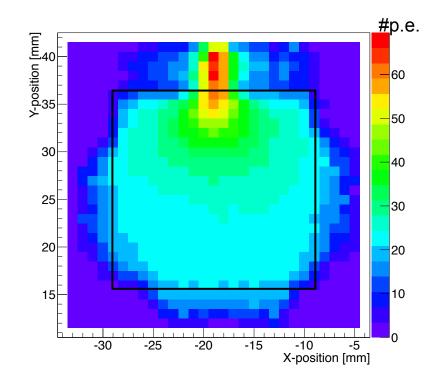


ESR foil vs reflective paint – same tile size



20x20x2 mm³:

- ESR foil
- Average response ~ 80 p.e.

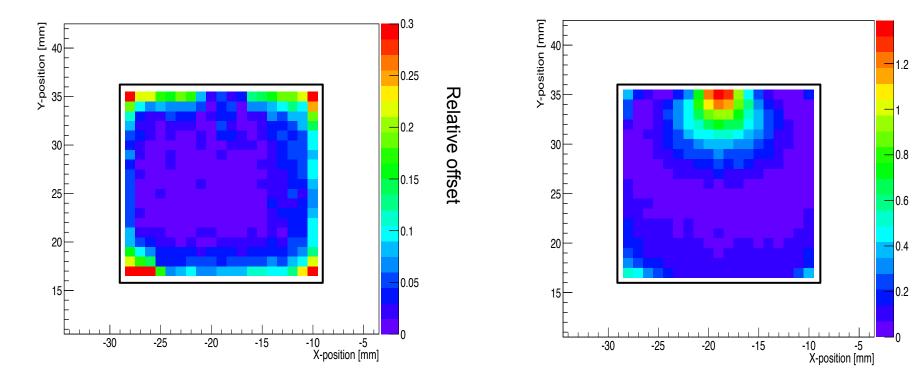


$20x20x2 \text{ mm}^3$:

- Diffuse reflector paint
- Average response ~ 25 p.e.
- Less uniform response.



ESR foil vs reflective paint – relative offsets



20x20x2 mm³:

- ESR foil
- Average response ~ 80 p.e.
- Uniformity within ~15% (excl. edges)

$20x20x2 \text{ mm}^3$:

- Diffuse reflector paint
- Average response ~ 25 p.e.
- Less uniform response.
- Uniformity within ~100%

Relative offse



Scan setup ready for ECAL tile study

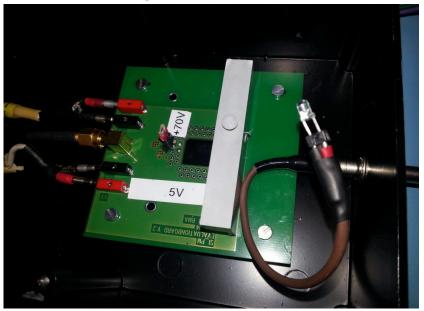
- Scanned three tiles, compared sizes and wrapping
 - Smaller tile has higher light yield & more uniform response
 - ESR foil results in better uniformity than diffuse paint
- Next:
 - Figure out left/right asymmetry
 - Test tiles of 15x15x2mm³

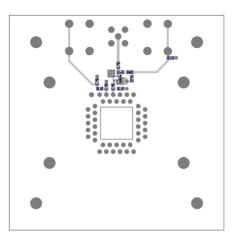


Backup

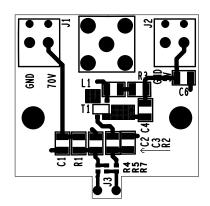


PCB design for readout based on testboard used:





- Shrinked to 2.5x2.5cm², with SiPM on 'nose'
- Including Pt1000 probe close to the SiPM

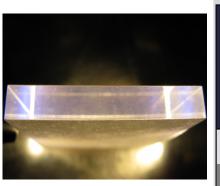


Tile uniformity

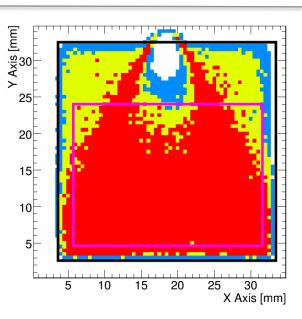
MPI München – C. Soldner

of

mean:



Part of the Scin- tillator Tile	Deviation of overall mean: 10.54	
91.7%	± 20%	
80.8%	±10%	
57.8%	± 5%	



	WITH DIMPLE	
	Part of the Scin- tillator Tile	Deviation overall m 18.432
	90.0%	±20%
and the second s	84.1%	±10%
	72.7%	±5%

